

Issue Classification				Application No.	Applicant(s)	
				09/932,943	MINAMIHABA ET AL.	
				Examiner	Art Unit	
				Hsien-Ming Lee	2823	

ORIGINAL				CROSS REFERENCE(S)				
CLASS		SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
438		633	438	637	672	687	692	693
INTERNATIONAL CLASSIFICATION								
H	0	1	L	21/4763	/	/	/	/
Hsien Ming Lee 9/8/03 (Assistant Examiner) (Date) <i>Lee</i>				W. DAVID COLEMAN PRIMARY EXAMINER <i>W. David Coleman 9/9/03</i> (Primary Examiner) (Date)				
Mark Short 9/11/03 (Legal Instruments Examiner) (Date)				Total Claims Allowed: 20				
				O.G. Print Claim(s)		O.G. Print Fig.		
				1		5C, 7		

<input type="checkbox"/> Claims renumbered in the same order as presented by applicant		<input type="checkbox"/> CPA		<input type="checkbox"/> T.D.		<input type="checkbox"/> R.1.47	
Final	Original	Final	Original	Final	Original	Final	Original
1	1	7	31	61	91	121	151
2	2	15	32	62	92	122	152
3	3	16	33	63	93	123	153
4	4	17	34	64	94	124	154
5	5	18	35	65	95	125	155
6	6	19	36	66	96	126	156
7	7	20	37	67	97	127	157
8	8	38	68	68	98	128	158
9	9	39	69	69	99	129	159
10	10	40	70	70	100	130	160
11	11	41	71	71	101	131	161
12	12	42	72	72	102	132	162
13	13	43	73	73	103	133	163
14	14	44	74	74	104	134	164
15	15	45	75	75	105	135	165
16	16	46	76	76	106	136	166
17	17	47	77	77	107	137	167
1	18	48	78	78	108	138	168
2	19	49	79	79	109	139	169
3	20	50	80	80	110	140	170
4	21	51	81	81	111	141	171
6	22	52	82	82	112	142	172
12	23	53	83	83	113	143	173
13	24	54	84	84	114	144	174
14	25	55	85	85	115	145	175
8	26	56	86	86	116	146	176
9	27	57	87	87	117	147	177
10	28	58	88	88	118	148	178
11	29	59	89	89	119	149	179
5	30	60	90	90	120	150	180
Final							
Original							

11050 U.S. PT
09/932943
08/24/01

633	Subclass
438	Class
ISSUE CLASSIFICATION	

PATENT NUMBER	
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U.S. UTILITY Patent Application

O.I.P.E. SCANNED	PATENT DATE MS4 OA SW
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APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/932943	F	438	633	1755 2812	L. I.

APPLICANTS
Jaku Mizamihara
Hiroyuki Yano
Nobuyuki Kurashima
Nobuo Kawahashi

TITLE
Slurry for chemical mechanical polishing and method of manufacturing semiconductor device

PTO-2040
1299

ISSUING CLASSIFICATION							
ORIGINAL		CROSS REFERENCE(S)					
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
438	633	438	637	672	687	692	693
INTERNATIONAL CLASSIFICATION							
H 01 L		21/4763					
<input type="checkbox"/> Continued on Issue Slip Inside File Jacket							

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
	6	16	50,7	20	1
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	Kris May Lee 9/8/03 (Assistant Examiner) (Date)			NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent No. _____				ISSUE FEE	
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	(Primary Examiner) (Date)			Amount Due	Date Paid
					ISSUE BATCH NUMBER

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